

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **ISHIKAWA, Mitsunori, et al.**

Group Art Unit: **1716**

Serial No.: **10/589,490**

Examiner: **CROWELL, Anna M.**

Filed: **May 22, 2007**

P.T.O. Confirmation No.: **8238**

For: **SEMICONDUCTOR MANUFACTURING DEVICE AND METHOD FOR  
MANUFACTURING SEMICONDUCTOR DEVICES**

**RESPONSE UNDER 37 CFR §1.116**  
**- EXPEDITED RESPONSE -**  
**GROUP ART UNIT 1716**

**MAILSTOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

April 19, 2011

Sir:

In response to the Office Action dated January 20, 2011, entry of the following amendments and remarks, further examination, and reconsideration are respectfully requested.

**Amendments to the Claims** are reflected in the listing of claims which begins on page two of this paper.

**Remarks/Arguments** begin on page four of this paper.